



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Paul B. Mirkarimi et al. Docket No. : CIL-10972
Serial No. : 10/086,614 Art Unit : 1762
Filed : March 1, 2002 Examiner : W. Markham
For : Ion-Assisted Deposition Techniques For
The Planarization Of Topological Defects

PETITION FOR EXTENSION OF TIME UNDER 37 CFR 1.136(a)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This is a request under the provisions of 37 CFR 1.136(a) to extend the period for filing a reply in the above identified application.

The requested extension fee for a two month extension (37 CFR 1.17(a)(2) is \$450.

The Commissioner is hereby authorized to charge this fee (\$450) to Deposit Account Number 501913.

If any impediments remain, please contact the undersigned at 808-875-0012.

Respectfully submitted,

John P. Wooldridge
Attorney for Applicant
Registration No. 38,725

Dated: February 8, 2006

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